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JAN 30 2004

OPTIONAL

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

5 Applicant: Chih-Ning Wu Examiner: Umez Eronini, Lynette T
Filing Date: 07/16/2001 Art Unit: 1765
App. No.: 09/682,054 Docket No.: NAUPO374USA

10 Title: EXTRUSION-FREE WET CLEANING PROCESS FOR COPPER-DUAL
DAMASCENE STRUCTURES

To: Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

15 Subject: Response to the Office action dated 09/23/2003 and the
Advisory action dated 01/02/2004

20 Dear Sir or Madame:

INTRODUCTORY COMMENTS

25 Please accept this reply as a replacement for the previous reply faxed November 21,
2003. The extension fee is submitted herein. In this reply, claims 8-19 are cancelled
without prejudice or disclaimer to the subject matter thereof to put the application in
condition for allowance. The applicant reserves the right to file continuation applications
for the cancelled claims.

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